IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OIPE IAP28 SEP 07 2005 PATENT & TRADEMARK OFFICE

Application Number:	10/684,596
Filing Date:	October 15, 2003
Applicant:	Ashima B. Chakravarti et al.
Application Title:	**DEPOSITION OF CARBON AND NITROGEN DOPED POLY SILICON FILMS, AND RETARDED BORON DIFFUSION AND IMPROVED POLY DEPLETION**
Examiner:	Schillinger, Laura M.
Art Unit:	2813

5/29/06 Ok to Enter

AMENDMENT UNDER 37 C.F.R. §1.116

Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This timely responds to the office action mailed June 14, 2005.

Listing of the Claims begins on page 2.

Remarks begin on page 3.